FORM PTO-1449 (Modified) SERIAL NO .: ATTY. DOCKET NO. LIST OF PATENTS AND PUBLICATIONS FOR YOR919990123US2 09/936,320 INFORMATION DISCLOSURE STATEMENT APPLICANT: Jack O. Chu (Use several sheets if necessary) FILING DATE: GROUP: September 12, 2001 2811 REFERENCE DESIGNATION U.S. PATENT DOCUMENTS **EXAMINER** DOCUMENT FILING DATE INITIALS NUMBER DATE NAME CLASS **SUBCLASS** (IF APPRO.) 5,019,882 05/28/1991 Solomon et al. 357 23.8 May 15, 1989 5,534,713 07/09/1996 Ismail et al. 257 24 May 20, 1994 AC 5,241,197 08/31/1993 Murakami et al. 257 192 September 13, 1991 AD 5,298,452 03/29/1994 Meyerson 437 81 February 21, 1992 ΑE 5,659,187 08/19/1997 Legoues et al. 257 190 June 7, 1995 ΑF 5,241,197 08/31/1993 Murakami et al. 257 192 September 13, 1991 AG 5,259,918 11/09/1993 Akbar et al. 156 610 June 12, 1991 FOREIGN PATENT DOCUMENTS DOCUMENT TRANSLATION NUMBER DATE COUNTRY CLASS SUBCLASS YES NO 05 121450 A 15/05/1993 Japan H01L 21/338 OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.) AM R. People and J.C. Bean, "Band Alignments Of Coherently Strained Ge<sub>x</sub> Si<sub>1-x</sub> / Si Heterostructures On <001> Ge<sub>y</sub>Si<sub>1-y</sub> Substrates"; Appl. Phys. Lett. 48 (8); pp. 538-539; February 24, 1986. AN G. Hock et al., "High Performance 0.25 $\mu$ m p-Type Ge/SiGe MODFETs"; Electronics Letters; Vol. 34; No. 19; pp. 1888-1889; September 17, 1998. AO U. Konig and F. Schaffler, "p-Type Ge-Channel MODFET's With High Transconductance Grown On Si Substrates"; IEEE Electron Device Letters; Vol. 14; No. 4; pp. 205-207; April 1993. EXAMINER DATE CONSIDERED

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